

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

INFORMATION DISCLOSURE STATEMENT

In re Patent Application of:)	
)	Group Art Unit: 2812
Masahiro Tada)	
)	Examiner: Not Yet Assigned
Application No. 10/551,271)	
Filed: September 28, 2005)	
For: PROCESS FOR FABRICATING)	
MICROMACHINE)	
)	

Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

S I R:

In accordance with the provisions of 37 C.F.R. § 1.56, Applicants request that citation and examination of the references identified on the attached PTO-SB08A form, in accordance with 37 C.F.R. §1.98, be made during the course of examination of the above-referenced application for United States Letters Patent. These references were cited in an Office Action issued on August 5, 2008, in connection with Japanese application no. JP2004-068325. Copies of the foreign references and machine translations are attached as is a copy of the Japanese office action.

Respectfully submitted,

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